

_	Application/Control No.	Applicant(s)/Patent u Reexamination		
	10/720,110	TAKAYUKI NAKAMI	JRA	
	Examiner	Art Unit		
	   Alex Liew	2624		

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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4/26/2007	AL
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4/28/2007	AL
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